

Notice of References Cited	Application/Control No.	Applicant(s)/Patent Under Reexamination	
	10/809,929	NAKAMURA ET AL.	
	Examiner	Art Unit	Page 1 of 1
	David S. Kim	2613	

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0035168 A1	02-2003	Qian et al.	359/124
*	B	US-6,545,782 B1	04-2003	Wang et al.	398/79
	C	US-			
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	F	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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